



UNITED STATES PATENT AND TRADEMARK OFFICE

28/12
#2
1-502
Harrison

In re PATENT Application of
Lu

Group Art Unit: Unknown

Application No. 09/838,316

Examiner: Unassigned

Filed: April 20, 2001

Att. Docket No.: 95-153

For: METHOD FOR FABRICATING SILICON-ON-INSULATOR MATERIAL

* * * * *

June 18, 2001

INFORMATION DISCLOSURE STATEMENT

Hon. Commissioner of Patents
and Trademarks
Washington, D.C. 20231

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JUN 21 2001
TC 2000 MAIL ROOM

Sir:

Attached is a PTO/SB/O8B form listing the enclosed documents.

This information disclosure statement is being filed within 3 months of the filing date.

This information disclosure statement is intended to be in full compliance with the rules, but should the Examiner find any part of its required content to have been omitted, prompt notice that effect is earnestly solicited, along with additional time under Rule 97(f), to enable Applicant to comply fully.

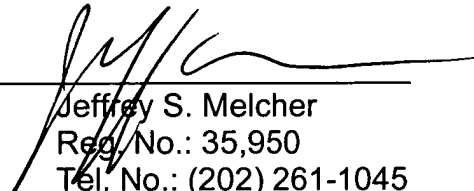
Lu
09/838,316
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Consideration of the foregoing and enclosures plus the return of a copy of the herewith PTO/SB/08B form with the Examiner's initials in the left column per MPEP 609 along with an early action on the merits of this application are earnestly solicited.

Respectfully submitted,

Manelli Denison & Selter PLLC

By


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